

Indian Nanoelectronics Users' Programme - Idea to Innovation (INUP-i2i)
Industry Training on "Vacuum Technology and Thin Film Deposition"
Indian Institute of Technology Delhi
28th September 2025



Workshop Coordinators:

Time (in Hours)	28 th September 2025, Sunday	Venue
10:00 – 10:30	Registration	Room No. MS 412, Physics Committee Room
10:30 – 11:00	Welcome Address and Introduction to INUP-i2i & Hands-on Training Program Prof. Neeraj Khare & Prof. Prashant Mishra	Room No. MS 412, Physics Committee Room
11:00 – 11:40	Lecture: Clean-Room Safety Prof. Bhaskar Mitra (Department of Electrical Engineering, IITD)	Room No. MS 412, Physics Committee Room
11:40 – 12:20	Lecture: E-beam Deposition/Thermal Evaporation Prof. Neeraj Khare (Department of Physics, IITD)	Room No. MS 412, Physics Committee Room
12:20 – 13:00	Discussion	Room No. MS 412, Physics Committee Room
14:00 – 15:30	Lecture: Vacuum Systems & Gauges Prof. Sujeet Chaudhary, IITD	Room No. MS 412, Physics Committee Room
15:30 – 16:00	Lecture: Atomic Layer Deposition (ALD) Prof. Samaresh Das (CARE, IITD)	Room No. MS 412, Physics Committee Room
16:00 – 17:00	NRF Visit	Room No. MS 412, Physics Committee Room